

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2851

03560.002558.

## **PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

negative .		
In re Application of:	)	
· · · · · · · · · · · · · · · · · · ·	:	Examiner: H. Nguyen
Yuji SUDOH et al.	)	
por de la companya de	:	Group Art Unit: 2851
Application No.: 09/532,022	)	175
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Filed: March 21, 2000	)	
<i>*</i>	:	
For: EXPOSURE APPARATUS AND A	)	August 5, 2003
DEVICE MANUFACTURING METHOD	:	
WHICH KEEP TEMPERATURE OF A	)	
DIAPHRAGM OF A PROJECTION	:	
OPTICAL SYSTEM SUBSTANTIALLY	)	
CONSTANT	:	
		•
Mail Stop AF		
The Commissioner for Patents		•
P.O. Box 1450		
Alexandria VA 22313-1450		

## **AMENDMENT AFTER FINAL ACTION**

Sir:

In response to the Office Action dated May 6, 2003, please amend the aboveidentified application as follows pursuant to 37 C.F.R. § 1.116:

The present Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice entitled "Amendments in a Revised Format Now Permitted," a copy of which is attached.